

Docket No. (AM5018/ISM/CORE/PJS)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

July 15, 2003

Commissioner of Patents and Trademarks Washington, D.C. 20231

Re: Inventor: Avi Tepman et al.

Title: Variable Flow Deposition Apparatus and Method in Semiconductor Substrate Processing

Serial No: 10/074,854 Filing Date: February 11, 2002

Transmitted herewith is a **Response to Restriction Requirement under 37 CFR § 1.143** in the above-identified patent application.

XX No additional fee is required.

The fees have been calculated or outlined below.

Fee Items	Claims Remaining After Amendment	Highest Number of Claims Previously Paid For	Present Extra Claims	Fee Rate	Total
Total Claims	51	51	0	X\$18.00	\$00.00
Independent Claims	6	6	0	X\$84.00	\$00.00

Applicant petitions for an extension of time, the fees for which are set out in 37 CFR 1.17(a)-(d), for the total number of months checked below:

Extension		Fee for other than		
(mor	nths)	small entity		
	One Month	\$110.00		
	Two Months	\$410.00		
	Three Months	\$930.00		
	Four Months	\$1,450.00		

If an additional extension of time is required please consider this a petition therefor.

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_	The Commissioner is hereby authorized to charge the total amount of to Deposit Account No. <u>50-1074</u> .
<u>xx</u>	The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. <u>50-1074</u> . A duplicate copy of this transmittal is enclosed.
	Respectfully submitted, Robert W. Mulcahy Attorney Registration No. 25,436

Mailed by Express Mailer Label No. **EL341110851US** addressed to: Box: NON Fee Amendment, Assistant Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA . 22313-1450.